## Applicant(s)/Patent Under Application/Control No. Reexamination 10/567,070 VAN DUUREN, MICHIEL JOS Notice of References Cited Examiner Art Unit Page 1 of 1 2827 Jason Lappas **U.S. PATENT DOCUMENTS Document Number** Date Classification Name Country Code-Number-Kind Code MM-YYYY \* 365/185.33 US-6,778,443 08-2004 Shiga et al. Hirakawa, Tsuyoshi US-2001/0007541 07-2001 365/233 В 365/189.01 С US-7,009,890 03-2006 Yamazoe et al. US-D US-F US-G US-Н US-US-J US-K US-US-М **FOREIGN PATENT DOCUMENTS Document Number** Date Classification Country Name Country Code-Number-Kind Code MM-YY Ν 0 Р Q R S Т NON-PATENT DOCUMENTS Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) U V W Х

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.